

IEC QUALITY ASSESSMENT SYSTEM (IECQ)

covering Electronic Components, Assemblies, Related Materials and Processes

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Schedule of Scope to Certificate of Approval Independent Testing Laboratory

IECQ Certificate No.: IECQ-L ULTW 16.0003-14
CB Certificate No.: 50600326 ITL

Schedule Number: IECQ-L ULTW 16.0003-14-S Rev No.: 1 Revision Date: 2024/08/07 Page 1 of 2

Appendix-1 (50600326 ITL) Schedule of Scope to Certificate of Approval

Description test	Standard	
Scanning Electron Microscope (SEM)	T-SEM-3	
Energy Dispersive Spectrometry of X-ray (EDS)	T-SEM-3, T-TEM-3	
X-Ray imaging	T-EFA-3	
Scanning Acoustic Tomography (SAT)	T-EFA-3	
Optical Microscope (OM)	T-OMI-3	
3D Optical Microscope (3D OM)	T-LAB-3	
IC Layout Imaging	T-OMI-3	
Circuitry analysis	T-OMI-3	
3D X-Ray microscope	T-EFA-3	
Nano Probe	T-EFA-3	
Secondary Ion Mass Spectrometry (SIMS)	T-SIM-3	
Atomic Force Microscope (AFM)	T-SIM-3	

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	Conductive atomic force microscopy (C-AFM)	T-SIM-3	3	
	Alpha-step stylus profiler	T-SIM-3	3	
	X-Ray Photoelectron Spectroscopy (XPS)	T-SIM-3	3	
	Scanning Capacitance Microscopy (SCM)	T-SIM-3	3	

Technical Reviewer of DQS: Paul Tay Date: 8/7/2024

